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JAN 22 2008

Practitioner's Docket No. 02153PCT

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Asahi Glass Co., Ltd.

Nippon Valqua Industries, Ltd.

Serial No.: 10/528,476 Filed: March 19, 2005

For: Sealing material for semiconductor device and method

for production thereof Examiner: Nathan M. Nutter

Group No.: 1796

Confirmation No.: 8461

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Amendment and Remarks--Introduction

Amendments to the Claims begin on page 2 of this paper.

The Remarks begin on page 7 of this paper.

(18450.DOC)

I hereby certify that this correspondence and the documents referred to as enclosed therein are being facsimile transmitted to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 21, 2008 to 1-571-273-8300 by applicant's afterney, Robert J. Jacobson.

(Amendment and Remarks--page 1 of 11)

Robert